

L Number	Hits	Search Text	DB	Time stamp
12	5	silicon and substrate same oxygen same nitrogen and lpd	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB USPAT	2003/01/09 14:37
-	0	silicon and substrate same oxygen same nitrogen and lls	US-PGPUB;	2003/01/09 14:36
-	3	silicon and substrate same oxygen same nitrogen and lls	EPO; JPO; DERWENT; IBM TDB USPAT;	2003/01/08 16:59
-	146	silicon same substrate same oxygen same nitrogen same epitaxial	US-PGPUB; EPO; JPO; DERWENT; IBM TDB USPAT	2003/01/08 17:28
-	1		USPAT	2003/01/08 17:17
-	1		USPAT	2003/01/08 17:18
-	1		USPAT	2003/01/08 17:18
-	1		USPAT	2003/01/08 17:18
-	22	silicon same substrate same oxygen same nitrogen same epitaxial same resistivity	US-PGPUB; EPO; JPO; DERWENT; IBM TDB USPAT	2003/01/08 17:29